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| (21) International Application Number: PCT/US97/07597 (22) International Filing Date: 6 May 1997 (06.05.97) (30) Priority Data: 08/642,921 6 May 1996 (06.05.96) US (71) Applicants: LIBBEY-OWENS-FORD CO. [US/US]; 811 Madison Avenue, Toledo, OH 43697 (US). PILKINGTON PLC [GB/GB]; Prescott Road, St. Helens, Merseyside WA10 3TT (GB). (72) Inventors: SOUBEYRAND, Michel, J.; 7935 North Shoreline Drive, Holland, OH 43528 (GB). HALLIWELL, Anthony, C.; 24 St. Georges Road, Formby, Merseyside L37 3HH (GB). (74) Agent: OBERLIN, Phillip, S.; Marshall & Melhorn, 8th floor, Four SeaGate, Toledo, OH 43604 (US). | | (81) Designated States: AM, AT, AU, BA, BB, BG, BR, BY, CA, CH, CN, CU, CZ, DE, DK, EE, ES, FI, GB, GE, HU, IL, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LT, LU, LV, MD, MG, MN, MW, MX, NO, NZ, PL, PT, RO, RU, SD, SE, SG, SI, SK, TJ, TM, TR, TT, UA, UG, UZ, VN, ARIPO patent (GH, KE, LS, MW, SD, SZ, UG), European patent (AT, BE, CH, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, ML, MR, NE, SN, TD, TG). Published <i>With international search report.</i> |
| (54) Title: METHOD FOR FORMING TIN OXIDE COATING ON GLASS | | |
| (57) Abstract <p>Fluorine doped tin oxide coatings on glass are prepared by providing a uniform, vaporized reactant mixture containing an organotin compound, HF, water and oxygen, and delivering the reactant mixture to the surface of the hot ribbon of glass, where the compounds react to form the fluorine doped tin oxide coating. The fluorine doped tin oxide coatings applied in accordance with the invention exhibit lower sheet resistance, and improved uniformity in sheet resistance over the coated surface of the glass.</p> | | |

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TITLE

METHOD FOR FORMING TIN OXIDE COATING ON GLASS

FIELD OF THE INVENTION

5 The present invention relates generally to a method for forming a tin oxide coating on glass, and more particularly, to a process for preparing a tin oxide coating doped with fluorine on a hot glass substrate by chemical vapor deposition.

10

BACKGROUND OF THE INVENTION

Typically, coated glass articles are produced by continuously coating a glass substrate while it is being manufactured in a process known in the art as the "Float Glass Process". This process involves casting glass onto a molten tin bath which is suitably enclosed, then transferring the glass, after it has sufficiently cooled, to take-away rolls which are aligned with the bath, and finally cooling the glass as it advanced across the rolls, initially through alehr and thereafter while exposed to the ambient atmosphere. A non-oxidizing atmosphere is maintained in the float portion of the process, while the glass is in contact with the molten tin bath, to prevent oxidation. An air atmosphere is maintained in the lehr.

25 The chemical vapor deposition (CVD) of various coatings may be conveniently performed in the bath or the lehr, or even in the transition zone therebetween, by contacting the surface of the hot glass with chemical vapor containing reactants which pyrolytically decompose to form the metal oxide coating. This, of course, requires that the chemical reactants have vaporization temperatures below their thermal decomposition temperatures. Several tin compounds

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exist which may be vaporized to prepare a tin oxide coating on glass by CVD technology.

The desirable performance characteristics of tin oxide coatings on glass, such as for example low emissivity, low sheet resistance, high light transmittance, high infrared reflectivity, etc., are improved by the incorporation into the tin oxide coating of a dopant. Several materials have been used in the prior art as dopants, but the most effective for tin oxide is the element fluorine. Fluorine may be supplied to the deposition reaction in the form of an organotin fluoride, or as a separate fluorine-containing compound which reacts in conjunction with a tin compound.

The physical form of the reactants employed in glass coating processes is generally a liquid, solid, vaporized liquid or solid, liquid or solid dispersed in a carrier gas mixture, or vaporized liquid or solid dispersed in a carrier gas mixture. The chemical vapor deposition process generally employs a vaporized liquid or solid, which is typically dispersed in a carrier gas mixture.

Both organic and inorganic tin compounds have been used for the deposition by chemical vapor deposition of fluorine doped tin oxide coatings. Thus, for example U.S. Patent No. 4,329,379 discloses a process for forming a fluorine doped tin oxide coating on a hot glass substrate by contacting the glass with the vaporized reactants of a tin tetrachloride, hydrofluoric acid (HF), air and water. Similarly, U.S. Patent No. 4,387,134 teaches that fluorine doped tin oxide films have sheet resistances of 1-10 ohm/square may be produced from a combination of vaporized water, methanol, HF, stannic chloride and H_2/N_2 gases.

Alternatively, other generally preferred methods for applying doped tin oxide coatings onto glass involve

vaporizing a mixture of an organic tin compound and a fluorine-containing compound, then directing these vaporized reactants onto the surface of a hot glass substrate. Such a method is disclosed in U.S. Patent No. 4,293,594, which additionally suggests the use of an oxygen-containing carrier gas.

Likewise, in U.S. Patent No. 4,590,096, a chemical vapor deposition method of forming fluorine doped tin oxide coatings is disclosed using a mixture of an organotin compound, an organic fluorine dopant, air and water vapor. In the method, the gas stream is said to contain sufficient water vapor such that the relative humidity of the gas stream at 18°C is about 6% to 100%.

In U.S. Patent No. 4,325,987, a CVD method is disclosed in which a gaseous mixture of tin tetrachloride and water vapor in a carrier gas containing at least 30% hydrogen is delivered to the glass surface. A separate gaseous mixture of HF and water vapor may also be delivered to the glass surface. While the preferred tin compound is stated to be tin tetrachloride and this is the only tin compound for which examples are given, mention is made of the possibility of using volatile tin compounds of the type Sn(Alk)_4 , where Alk denotes a lower alkyl radical and dibutyl-diacetyl tin. As there is a lack of any information on how to practice the method of the invention with the mentioned organic tin compounds, the disclosure does not contribute anything to the advancement of the state of the art in this regard.

It must be noted that the prior art referred to hereinabove has been collected and examined only in light of the present invention as a guide. It is not to be

inferred that such diverse art would otherwise be assembled absent the motivation provided by the present invention.

It would be desirable to improve the heretofore known methods for applying a fluorine doped tin oxide coating to a surface of a hot glass substrate by a CVD process, and thereby enhance the low sheet resistance and uniformity of the sheet resistance of the coated glass product. It would also be desirable to provide a method for applying a fluorine doped tin oxide coating to a surface of a hot glass substrate which was less costly than the heretofore known methods.

SUMMARY OF THE INVENTION

The present invention is directed toward a chemical vapor deposition process for applying a fluorine doped tin oxide coating to a surface of a hot glass substrate. Surprisingly, it has been discovered that the desirable properties of fluorine doped tin oxide coatings on glass are improved by utilizing a process comprising the steps of: a) providing a hot glass substrate, including a surface upon which a fluorine doped tin oxide coating is to be deposited; b) providing a uniform, vaporized reactant mixture containing an organotin compound, hydrogen fluoride, oxygen and water; and c) delivering the vaporized reactant mixture to the surface of the hot glass substrate; wherein the uniform, vaporized reactant mixture reacts to deposit a coating of fluorine doped tin oxide on the surface of the hot glass substrate.

In a preferred embodiment, a sodium diffusion barrier, preferably a layer of silica, is applied to the surface of the glass substrate prior to the deposition of the fluorine doped tin oxide. The process of the present invention is

particularly suitable for the production of glass having a fluorine doped tin oxide coating, useful for energy efficient architectural windows, airplane or automobile windows, and a variety of optical and electronic devices.

5

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENT

Tin oxide coatings doped with fluorine may be deposited onto the surface of a hot glass substrate by a process generally known in the art as chemical vapor deposition (CVD). In accordance with this process, the reactants are combined so as to form a uniform, vaporized reactant stream which is delivered to the surface of the hot glass substrate, wherein the vaporized reactant stream reacts to deposit a coating of fluorine doped tin oxide on the surface of the hot glass substrate. In the oxidizing atmosphere, which must exist at the surface of the hot glass, the organotin coating compounds pyrolytically decompose to form the tin oxide coating.

The process is typically conducted during the manufacture of glass by the float glass process, and occurs in the float metal bath, the lehr, or in the transition zone between the bath and the lehr, while the glass is still hot. The glass substrate is generally provided at a temperature in the range from about 750°F to about 1500°F. These are typical temperatures for glass during various stages as it is manufactured by the float glass process.

The glass substrates suitable for use in the process according to the present invention include any of the conventional glass substrates known in the art for the preparation of coated glass articles. A typical glass substrate, used in the manufacture of vehicle windows and plate glass, is commonly referred to as soda-lime-silica

glass. Other suitable glasses may be generally designated as alkali-lime-silica glass, boro-silicate glass, alumino-silicate glass, boro-alumino silicate glass, phosphate glass, fused silica, etc., as well as combinations thereof.

5 A preferred glass is soda-lime-silica glass.

The CVD reactant stream of this invention includes an organotin coating compound which is vaporized and conveyed to a point at or near the surface of the advancing glass ribbon. Suitable organotin compounds useful for practicing
10 the invention include, without limitation to those specifically recited, dimethyltin dichloride, diethyltin dichloride, dibutyltin diacetate, tetramethyl tin, methyltin trichloride, triethyltin chloride, trimethyltin chloride, ethyltin trichloride, propyltin trichloride,
15 isopropyltin trichloride, sec-butyltin trichloride, t-butyltin trichloride, phenyltin trichloride, carbethoxyethyltin trichloride, and the like, as well as combinations thereof. These compounds are generally well known in the art of CVD technology, as well as commercially
20 available, as precursors for applying a tin oxide coating on hot glass. A preferred organotin compound is dimethyltin dichloride. The organotin compound, and optionally a carrier gas, oxidizer, stabilizer, hydrocarbon, inert gas, and the like, are vaporized to form
25 a gaseous organotin reactant stream. The term gaseous organotin reactant stream, as used herein, typically comprises a vaporized organotin compound, an oxidizer, and an inert carrier gas.

The vaporized organotin compound may be prepared by
30 any of the procedures generally known in the art, such as for example the vaporization of dispersed or fluidized organotin powders or the vaporization of organotin

particles in a packed bed by a hot carrier gas stream, or the injection of a solubilized organotin compound into a hot carrier gas stream, or the bubbling of a carrier gas through a liquid organotin compound. These processes are more fully set forth in U.S. Patents, Nos. 3,852,098; 2,780,553; 4,351,861; 4,571,350; 3,970,037; 4,212,663; and 4,261,722, which are incorporated herein in their entirety by reference thereto. A preferred method for preparing the reactant stream containing the vaporized organotin compound is to vaporize the compound in a thin film evaporator in the presence of a blend gas, as is disclosed, for example, in U.S. Patent No. 5,090,985, which is also incorporated herein in its entirety by reference thereto. As noted above, this gaseous stream, which generally comprises an inert carrier gas such as helium, nitrogen, or argon, or mixtures thereof, may optionally contain oxidizers such as water or oxygen. Preferred carrier gases are helium and nitrogen, and mixtures thereof, containing oxygen as an oxidizer. The resultant reactant stream containing the vaporized organotin compound is generally heated to a temperature from about 250°F to about 450°F, then conveyed to the reaction zone at the surface of the hot glass substrate.

Gaseous hydrogen fluoride or hydrofluoric acid ("HF" is used herein to refer to either hydrogen fluoride gas or hydrofluoric acid) is combined with the vaporized organotin compounds. A separate HF containing reactant stream is formed generally comprised of HF and a carrier, preferably water vapor. The addition of water to the HF-containing reactant stream also lowers the emissivity of the coated glass, while increasing the growth rate of the fluorine doped tin oxide deposited. The HF-containing reactant

stream may additionally contain conventional adjuvants such as for example helium, nitrogen, or argon, and mixtures thereof, as well as oxidizers such as for example oxygen.

5 The HF-containing reactant stream is combined with the organotin reactant stream at a point prior to delivery of the reactants to the surface of the hot glass substrate upon which the coating is to be deposited, but preferably in relatively close proximity thereto. The reactant stream containing the HF may be prepared by vaporizing the
10 compound using one of the methods discussed hereinabove relative to the vaporization of the organotin, or by providing the HF as a gas. The vaporized reactant stream containing the HF may be combined with the reactant stream containing the vaporized organotin compound by blending the
15 two gaseous streams prior to delivery to the surface of the hot glass substrate. Alternatively, the HF-containing reactant stream in liquid or solution form may be injected into the hot reactant stream containing the vaporized organotin compound, thereby vaporizing the fluorine-
20 containing solution or liquid compound. After combination, the vaporized reactants of organotin, HF, water and oxygen are delivered to the surface of the hot glass, where they react together to deposit thereon a coating of fluorine doped tin oxide.

25 In a preferred embodiment, the organotin reactant stream is formed by vaporizing dimethyltin dichloride and an inert carrier gas, such as nitrogen, helium or a mixture thereof in an evaporator such as that described above. The resulting gaseous stream is then combined with gaseous
30 oxygen. At the same time, HF and water are combined in a second evaporator, and the resulting gaseous reactant stream of HF and water vapor is combined with the gaseous

organotin reactant stream to form a uniform, gaseous reactant stream. The uniform, gaseous reactant stream is delivered to the surface of the hot glass substrate, wherein a coating of fluorine doped tin oxide is deposited on the surface of the hot glass substrate. The uniform, gaseous reactant stream may be delivered to the surface of the glass by any suitable coating device. One preferred coating device is illustrated in U.S. Patent No. 4,504,526, which is incorporated herein in its entirety by reference thereto.

The uniform, gaseous reactant mixture which is delivered to the surface of the hot glass substrate in accordance with the invention preferably includes (all percentages being mole %) from about 10 to about 60% oxygen, from about 2 to about 50 % water, and from about 0.2 to about 2% HF, and most preferably includes from about 30 to about 50% oxygen, from about 15 to about 35% water, and from about 0.5 to about 1.5% HF. The uniform, gaseous reactant mixture also includes an organotin compound, the desired concentration of which is a function of the desired thickness of the tin oxide coating and the line speed of the substrate. Thus, as will be appreciated by those skilled in the art, the organotin is provided in the gaseous reactant mixture in an amount sufficient to apply a coating of the desired thickness at the desired line speed of the substrate. For typical commercial operations, the gaseous reactant mixture will generally include from about 0.01 to about 8% of the organotin.

It has also been noted to be preferable, when forming a fluorine doped tin oxide coating in accordance with this invention, to apply a layer of a material which acts as a sodium diffusion barrier between the glass substrate and

the fluorine doped tin oxide coating. Coated glass articles have been found to exhibit lower emissivity, lower sheet resistance and lower haze when the fluorine doped tin oxide coating deposited in accordance with the invention is applied to the glass with a sodium diffusion layer therebetween, as opposed to directly on the glass. This sodium diffusion layer is preferably formed of silica. The layer of silica is preferably formed using conventional CVD techniques.

10 In a most preferred embodiment, a thin film of tin oxide is first deposited on the surface of the hot glass substrate, with the thin film of silica deposited thereover, so that an underlayer structure of tin oxide/silica is formed intermediate the glass and the subsequently deposited layer of fluorine doped tin oxide. In this embodiment, the silica film not only acts as a sodium diffusion barrier but, in combination with the first (undoped) tin oxide film, helps to suppress iridescence in the resulting coated glass article. The use of such anti-iridescent layers is disclosed in U.S. Patent No. 20 4,377,613, which is incorporated herein in its entirety by reference thereto.

It must be noted that the process conditions are not sharply critical for the successful combining and delivering of vaporized reactants according to the present invention. The process conditions described hereinabove are generally disclosed in terms which are conventional to the practice of this invention. Occasionally, however, the process conditions as described may not be precisely applicable for each compound included within the disclosed scope. Those compounds for which this occurs will be readily recognizable by those ordinarily skilled in the

art. In all such cases, either the process may be successfully performed by conventional modifications known to those ordinarily skilled in the art, e.g., by increasing or decreasing temperature conditions, by varying the rates of combination of the organotin and HF reactants, by
5 routine modifications of the vaporization process conditions, etc., or other process conditions which are otherwise conventional will be applicable to the practice of the invention.

10 It will also be noted that the process of the invention may be repeated as desired on a given substrate so as to form a coating consisting of several successive layers, the composition of each of the layers not necessarily being identical. It is of course obvious that
15 for a given flow rate of the reactants, the thickness of a coating layer depends on the rate of movement of the substrate. Under these conditions, the reaction stations may if desired be multiplied by juxtaposing two or more coating devices. In this way, successive layers are
20 superimposed before the layers have had time to cool, producing a particularly homogenous overall coating.

The invention is more easily comprehended by reference to specific embodiments which are representative of the invention. It must be understood, however, that the
25 specific embodiments are provided only for the purpose of illustration, and that the invention may be practiced otherwise than as specifically illustrated without departing from its spirit and scope.

COMPARATIVE EXAMPLE

Dimethyltin dichloride is melted and then vaporized in a thin film evaporator of the type illustrated in U.S. Patent No. 5,090,985. Helium, as a carrier gas, is
5 simultaneously introduced into the thin film evaporator. The thin film evaporator is equipped with a steam jacket maintained at about 350°F. The resulting mixture of gaseous DMT and helium exits the thin film evaporator and is conveyed along a main reactant line. Gaseous oxygen is
10 introduced into the DMT/He gas stream in the main reactant line. The resultant gas stream continues along the main reactant line.

At the same time, trifluoroacetic acid (TFA) and water are fed into a second thin film evaporator, maintained at
15 about 400°F. The resulting mixture of gaseous TFA and water exits the second thin film evaporator and is fed through a supply line which joins with the main precursor line, combining the TFA/water gas mixture with the DMT/He/O₂ gas stream so that the streams are thoroughly
20 mixed to form a uniform, vaporized reactant stream. The final gaseous reactant stream consists of about (all percentages being mole %) 44.2% oxygen, 22.1% water, 30.2% helium, 0.97% TFA, and 2.53% DMT, with the total gas flow of the final gaseous mixture being about 384 standard
25 liters per minute per meter width of the resulting coated glass article.

This vaporized reactant stream is immediately delivered, utilizing the coating device of U.S. Patent No. 4,504,526, to the surface of a ribbon of glass on which a
30 first thin film of tin oxide and a second thin film of silica had been previously deposited by conventional CVD techniques. The ribbon of glass is moving at a line speed

of approximately 466 inches per minute, and is at a temperature of from about 1,100°F to 1,200°F. The reactant stream reacts at the surface of the hot glass to form a coating of fluorine doped tin oxide overlying the silica and tin oxide films. The thickness of the resulting layer of fluorine doped tin oxide is approximately 3,200 Å.

The sheet resistance is measured in 2 inch increments across the width of the resulting coated glass article. The sheet resistance ranges from 13.3 to 18.0 ohms per square, with an average sheet resistance of 14.4 ohms per square.

EXAMPLE

Dimethyltin dichloride is melted and then vaporized in a thin film evaporator of the type illustrated in U.S. Patent No. 5,090,985. Helium, as a carrier gas, is simultaneously introduced into the thin film evaporator. The thin film evaporator is equipped with a steam jacket maintained at about 350°F. The resulting mixture of gaseous DMT and helium exits the thin film evaporator and is conveyed along a main reactant line. Gaseous oxygen is introduced into the DMT/He gas stream in the main reactant line. The resultant gas stream continues along the main reactant line.

At the same time, an aqueous solution of HF is fed into a second thin film evaporator, maintained at about 400°F. Additional water is introduced into the second thin film evaporator. The resulting mixture of gaseous HF and water exits the second thin film evaporator and is fed through a supply line which joins with the main precursor line, combining the HF/water gas mixture with the DMT/He/O₂ gas stream so that the streams are thoroughly mixed to form

a uniform, vaporized reactant stream. The final gaseous mixture consists of about (all percentages being mole %) 42.9% oxygen, 24.6% water, 29.3% helium, 0.70% HF, and 2.5% DMT, with the total gas flow of the final gaseous mixture being about 395 standard liters per minute per meter width of the resulting coated glass article.

This vaporized reactant stream is immediately delivered, utilizing the coating device of U.S. Patent No. 4,504,526, to the surface of a ribbon of glass on which a first thin film of tin oxide and a second thin film of silica had been previously deposited by conventional CVD techniques. The ribbon of glass is moving at a line speed of approximately 466 inches per minute, and is at a temperature of from about 1,100°F to 1,200°F. The reactant stream reacts at the surface of the hot glass to form a coating of fluorine doped tin oxide overlying the silica and tin oxide films. The thickness of the resulting layer of fluorine doped tin oxide is approximately 3,200 Å.

The sheet resistance is measured in 2 inch increments across the width of the resulting coated glass article. The sheet resistance ranges from 13.0 to 15.9 ohms per square, with an average sheet resistance of 14.0 ohms per square.

WHAT IS CLAIMED IS:

1. A chemical vapor deposition process for applying a fluorine doped tin oxide coating to a surface on a hot glass substrate, comprising the steps of:

- 5 A) providing a hot glass substrate,
 including a surface upon which a fluorine doped
 tin oxide coating is to be deposited;
- B) providing a uniform, vaporized reactant
 mixture containing an organotin compound,
10 hydrogen fluoride, oxygen and water; and
- C) delivering the vaporized reactant mixture
 to the surface on the hot glass substrate;
 wherein the uniform, vaporized reactant
 mixture reacts to deposit a coating of fluorine
15 doped tin oxide on the surface of the hot glass
 substrate.

2. The process according to Claim 1, wherein the
glass is selected from the group consisting of soda-lime-
20 silica glass, alkali-lime-silica glass, boro-silicate
 glass, alumino-silicate glass, phosphate glass, fused
 silica glass, and combinations thereof.

3. The process according to Claim 1, wherein the
25 glass is soda-lime-silica glass.

4. The process according to Claim 1, wherein the organotin compound is selected from the group consisting of dimethyltin dichloride, diethyltin dichloride, dibutyltin diacetate, tetra methyl tin, methyltin trichloride, 5 triethyltin chloride, trimethyltin chloride, ethyltin trichloride, propyltin trichloride, isopropyltin trichloride, sec-butyltin trichloride, t-butyltin trichloride, phenyltin trichloride, carbethoxyethyltin trichloride, and combinations thereof.

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5. The process according to Claim 1, wherein the organotin compound is dimethyltin dichloride.

6. The process according to Claim 1, wherein the 15 glass substrate is provided at a temperature from about 750°F to about 1,500°F.

7. The process according to Claim 1, wherein the uniform, vaporized reactant mixture additionally comprises 20 one or more compounds selected from the group consisting of helium, nitrogen, argon, and nitrous oxide.

8. The process according to Claim 1, further comprising the step of depositing on said surface of said 25 hot glass substrate a layer of a material which acts as a sodium diffusion barrier, so that said material is interposed between said surface of said glass substrate and said fluorine doped tin oxide coating.

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9. The process according to Claim 8, wherein a layer of silica is deposited on the surface of said hot glass substrate prior to the deposition of said fluorine doped tin oxide coating.

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10. The process according to Claim 9, wherein said layer of silica is deposited on the surface of said hot glass substrate by a chemical vapor deposition process.

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11. The process according to Claim 9, wherein a layer of tin oxide is deposited on the surface of said hot glass substrate prior to the deposition of said layer of silica.

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12. The process according to Claim 1, wherein said gaseous reactant mixture includes from about 0.2 to about 2 mole % hydrogen fluoride.

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13. The process according to Claim 2, wherein said gaseous reactant mixture includes from about 0.5 to about 1.5 mole % hydrogen fluoride.

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14. The process according to Claim 1, wherein said gaseous reactant mixture includes from about 2 to about 50 mole % water.

15. The process according to Claim 14, wherein said gaseous reactant mixture includes from about 15 to about 35 mole % water.

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16. The process according to Claim 1, wherein said gaseous reactant mixture includes from about 10 to about 60 mole % oxygen.

17. The process according to Claim 16, wherein said gaseous reactant mixture includes from about 30 to about 50 mole % oxygen.

5 18. A chemical vapor deposition process for applying a fluorine doped tin oxide coating to a surface on a hot glass substrate, comprising the steps of:

10 A) providing a hot glass substrate at a temperature from about 750°F to about 1,500°F, including a surface upon which a fluorine doped tin oxide coating is to be deposited;

15 B) providing a uniform, vaporized reactant mixture containing an organotin compound, from about 0.2 to about 2 mole % hydrogen fluoride, from about 2 to about 50 mole % water, and from about 10 to about 60 mole % oxygen; and

C) delivering the vaporized reactant mixture to said surface on the hot glass substrate;

20 wherein the uniform, vaporized reactant mixture reacts to deposit a coating of fluorine doped tin oxide on the surface of the hot glass substrate.

19. A chemical vapor deposition process for applying a fluorine doped tin oxide coating to a surface on a hot glass substrate, comprising the steps of:

5 A) providing a hot glass substrate at a temperature from about 750°F to about 1,500°F, including a surface upon which a fluorine doped tin oxide coating is to be deposited, said surface having a layer of silica applied thereto;

10 B) providing a uniform, vaporized reactant mixture containing an organotin compound, from about 0.2 to about 2 mole % hydrogen fluoride, from about 2 to about 50 mole % water, and from about 10 to about 60 mole % oxygen; and

15 C) delivering the vaporized reactant mixture to said surface on the hot glass substrate;

wherein the uniform, vaporized reactant mixture reacts to deposit a coating of fluorine doped tin oxide on said layer of silica on the surface of the hot glass substrate.

INTERNATIONAL SEARCH REPORT

International application No.
PCT/US97/07597

A. CLASSIFICATION OF SUBJECT MATTER

IPC(6) :C23C 16/00; B05D 5/12

US CL :427/255.3, 255.2, 255.1, 255, 109, 166, 167, 419.3; 65/60.52

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

U.S. : 427/255.3, 255.2, 255.1, 255, 109, 166, 167, 419.3; 65/60.52

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched
APSElectronic data base consulted during the international search (name of data base and, where practicable, search terms used)
"FLOURINE DOPEND TIN OXIDE", "HOT GLASS", "SILICA OR SILICON OXIDE", "DIMETHYLTIN"**C. DOCUMENTS CONSIDERED TO BE RELEVANT**

| Category* | Citation of document, with indication, where appropriate, of the relevant passages | Relevant to claim No. |
|-----------|--|-----------------------|
| A | US 4,329,379 A (TERNEU ET AL), 11 May 1982 see example 1 | 1-19 |
| A | US 4,590,096 A (LINDNER), 20 May 1986 see column 21, line 10 through column 22, line 46 | 1-19 |
| A | US 4,771,015 A (KANAI ET AL), 13 September 1988 see column 7, line 67 through column 8, line 2 | 1-19 |
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☐ Further documents are listed in the continuation of Box C. ☐ See patent family annex.

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Box PCT
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Facsimile No. (703) 305-3230

Authorized officer

f. Roy V. King

Telephone No. 703-308-0661